

APPLICATION DATA SHEET

Application Information	
Application Type::	Regular
Subject Matter::	Utility
Suggested Classification::	
Suggested Group Art Unit::	
CD-ROM or CD-R::	None
Title::	Silicon Carbide Epitaxial Wafer, Method for Producing such Wafer, and Semiconductor Device Formed on Such Wafer
Attorney Docket Number::	OGOSH46USA
Request for Early Publication?	No
Request for Non-Publication?	No
Suggested Drawing Figure::	1b
Total Drawing Sheets::	3
Small Entity::	No
Petition Included::	No
Secrecy Order in Parent Application::	No

Applicant Information	
Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Kazutoshi
Middle Name::	
Family Name::	Kojima
Name Suffix::	
City of Residence::	Ibaraki
State or Province of Residence::	
Country of Residence::	Japan
Street of Mailing Address::	c/o National Institute of Advanced Industrial Science and Technology, Tsukuba Central 2 1-1, Umezono 1-chome, Tsukuba-shi
City of Mailing Address::	Ibaraki
State or Province of Mailing Address::	
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	3058568

Applicant Information	
Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Satoshi
Middle Name::	
Family Name::	Kuroda
Name Suffix::	
City of Residence::	Ibaraki
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Country of Residence::	Japan
Street of Mailing Address::	c/o National Institute of Advanced Industrial Science and Technology, Tsukuba Central 2 1-1, Umezono 1-chome, Tsukuba-shi
City of Mailing Address::	Ibaraki
State or Province of Mailing Address::	
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	3058568

Applicant Information	
Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hajime
Middle Name::	
Family Name::	Okumura
Name Suffix::	
City of Residence::	Ibaraki
State or Province of Residence::	
Country of Residence::	Japan
Street of Mailing Address::	c/o National Institute of Advanced Industrial Science and Technology, Tsukuba Central 2 1-1, Umezono 1-chome, Tsukuba-shi
City of Mailing Address::	Ibaraki
State or Province of Mailing Address::	
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Postal or Zip Code of Mailing Address::	3058568

Correspondence Information	
Correspondence Customer Number::	00270
Phone Number::	215-540-9216
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E-Mail Address::	wbak@howsonandhowson.com

Representative Information		
Representative Customer No. ::	00270	

Domestic Priority Information			
Application	Continuity Type	Parent Application	Parent Filing Date
This Application	National Stage of	PCT/JP2004/011894	08/19/04

Foreign Priority Information			
Country	Application Number	Filing Date	Priority Claimed
Japan	2003-295413	08/19/03	Yes

Assignee Information	
Assignee Name::	National Institute of Advanced Industrial Science and Technology
Street of Mailing Address::	3-1, Kasumigaseki 1-chome, Chiyoda-ku
City of Mailing Address::	Tokyo
State or Province of Mailing Address::	
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	100-8921